

Message Text

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PAGE 01 STATE 179888

71

ORIGIN EB-11

INFO OCT-01 CIAE-00 COME-00 DODE-00 NSAE-00 RSC-01 TRSE-00

EUR-25 AEC-11 EA-11 ISO-00 DRC-01 /061 R

DRAFTED BY EB/ITP/EWT:JMGREGORYJR.

9/10/73 EXT 20442

APPROVED BY EB/ITP/EWT:RBWRIGHT

COMMERCE/OEC:KSEASWORD

RPE

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P 110117Z SEP 73

FM SECSTATE WASHDC

TO USMISSION OECD PARIS PRIORITY

C O N F I D E N T I A L STATE 179888

EXCON

E.O. 11652: XGDS-1

TAGS: ESTC,COCOM, JA, PL

SUBJECT: JAPANESE POLYCRYSTALLINE SILICON PLANT TO POLAND -
IL 1355

REF: A. COCOM DOC(73) 1662

B. COCOM DOC(73) 933

NO OBJECTION TO REF A FOR SIMILAR REASONS TO THOSE PROFFERED

REF B. RUSH

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 JAN 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: EXCEPTIONS LIST, SILICON
Control Number: n/a
Copy: SINGLE
Draft Date: 11 SEP 1973
Decaption Date: 01 JAN 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Authority: morefirh
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 28 MAY 2004
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1973STATE179888
Document Source: CORE
Document Unique ID: 00
Drafter: JMGREGORYJR.
Enclosure: n/a
Executive Order: X1 WRIGHT
Errors: N/A
Film Number: n/a
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1973/newtext/t19730942/aaaabexn.tel
Line Count: 43
Locator: TEXT ON-LINE
Office: ORIGIN EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators:
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: A. COCOM DOC(73) 1662
Review Action: RELEASED, APPROVED
Review Authority: morefirh
Review Comment: n/a
Review Content Flags:
Review Date: 23 AUG 2001
Review Event:
Review Exemptions: n/a
Review History: RELEASED <23-Aug-2001 by shawdg>; APPROVED <19-Nov-2001 by morefirh>
Review Markings:

Declassified/Released
US Department of State
EO Systematic Review
30 JUN 2005

Review Media Identifier:
Review Referrals: n/a
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
Secure: OPEN
Status: NATIVE
Subject: JAPANESE POLYCRYSTALLINE SILICON PLANT TO POLAND - IL 1355
TAGS: ESTC, JA, PL, COCOM
To: OECD PARIS
Type: TE
Markings: Declassified/Released US Department of State EO Systematic Review 30 JUN 2005